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## **Novel Plastic Microchannel-Based Direct Fast Neutron Detection**

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## Outline

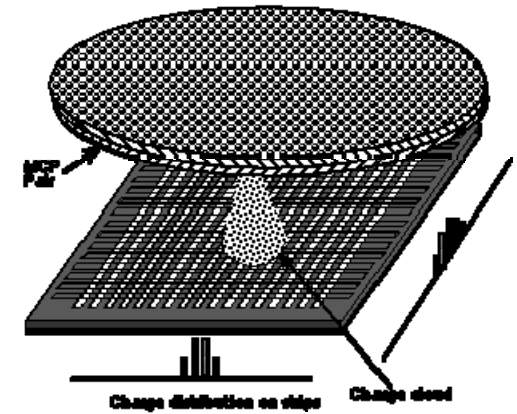
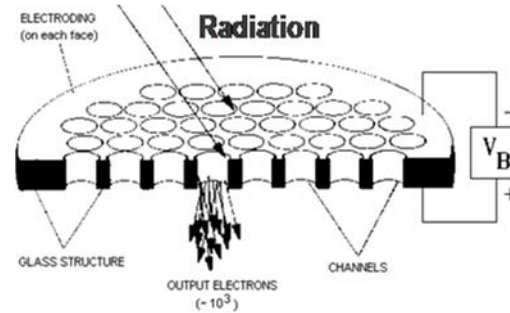
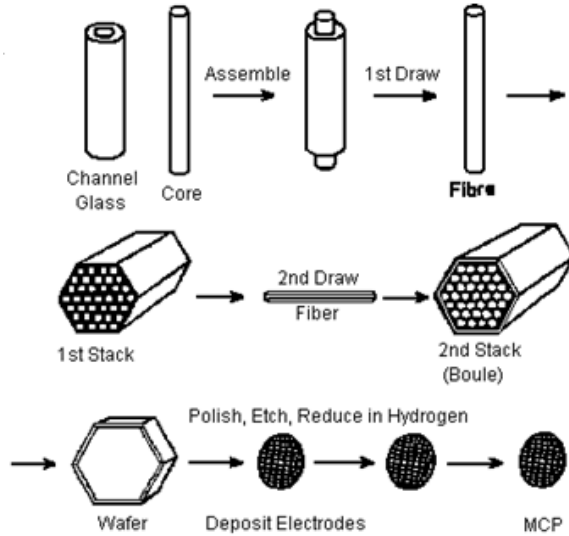
- ◆ Microchannel plate (MCP) background
- ◆ Arradiance functional thin film technology
  - ◆ Atomic Layer Deposition (ALD)
- ◆ Substrate independent MCP technology
  - ◆ Secondary electron emissive films
  - ◆ Conductive films
- ◆ Fast neutron MCP detector
  - ◆ Concept
  - ◆ Functionality
  - ◆ Simulation
- ◆ Fast neutron MCP detector experimental
- ◆ Fast neutron MCP detector results
- ◆ Summary and Future Work



# MicroChannel Plate (MCP) Technology

- ◆ Mature (1960s) MFG, Expensive, Bulk materials determine performance, High Z content, limited size (<10cm), difficult process control

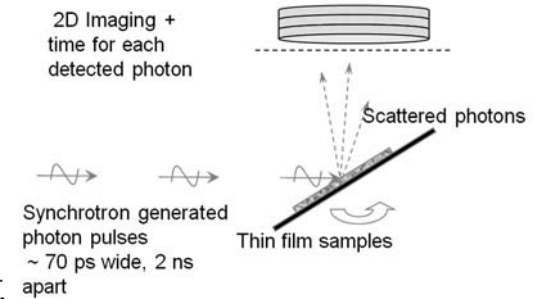
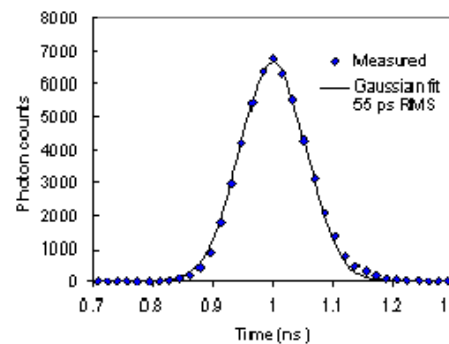
- ◆ Event counting:  $>10^7$  gain,  $<0.01$  c/cm<sup>2</sup>-s noise, high efficiency,  $<10\mu\text{m}$  spatial resolution,  $<50\text{ps}$  rms temporal resolution



Elemental composition of MCP glass<sup>2</sup>.

Z	Element	Weight percent
82	Pb	47.8
8	O	25.8
14	Si	18.2
19	K	4.2
37	Rb	1.8
56	Ba	1.3
33	As	0.4
55	Cs	0.2
11	Na	0.1

<sup>2</sup>Density - 4.0 g/cm<sup>3</sup>.



A. S. Tremsin, et al., Nucl. Instr. Meth. A 580, pp.853-857 (2007)

Wiza, Nuclear Inst. & Meth., Vol 162, 1979, 587

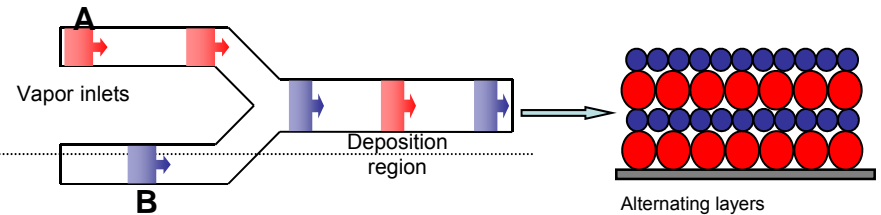


# ALD MCP Technology

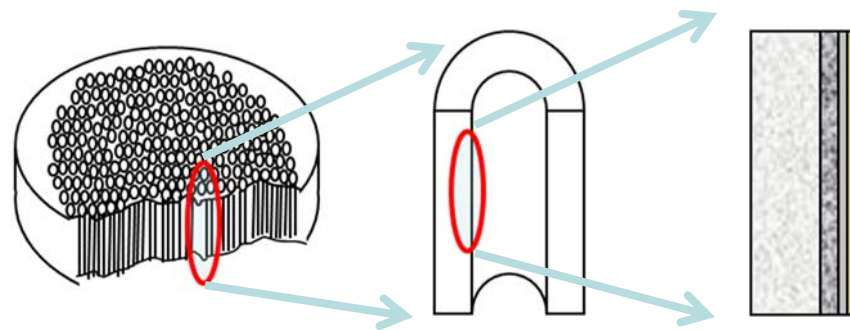
## ◆ MCP performance tied to glass composition

ALD:

- ◆ Device optimization is decoupled from substrate.
- ◆ Semiconductor processes & process control.
- ◆ Materials engineering at the nanoscale
- ◆ Functional films composed of abundant, non-toxic materials.
- ◆ Advantages:
  - ◆ High conformality (>500: 1)
  - ◆ Scalable to large areas
  - ◆ Digital thickness control
  - ◆ Pure films
  - ◆ Control over film composition
  - ◆ Low deposition temperatures (50-300°C)

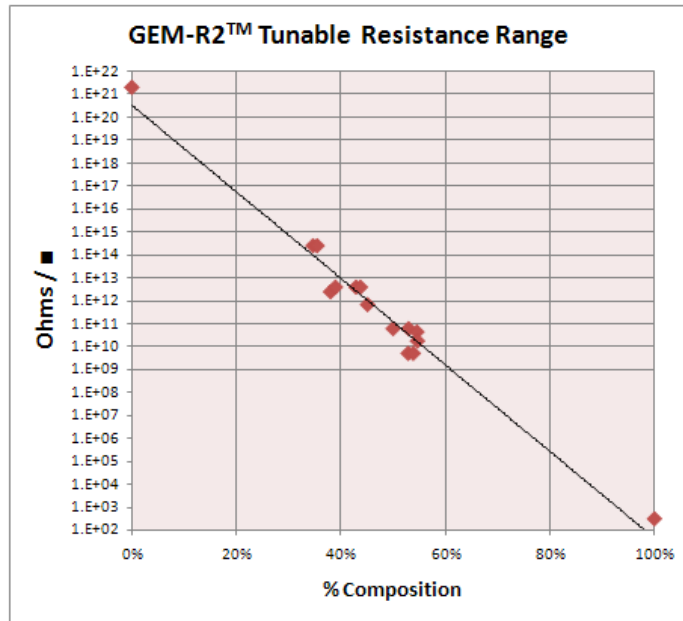
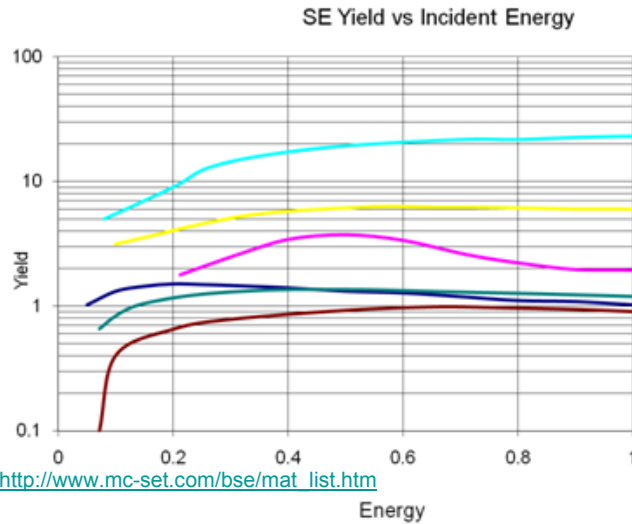


- ◆ Thin film growth that relies on self-limiting surface reactions
- ◆ Gas A reacts with a surface
  - ◆ excess precursor & reaction by-product removed.
- ◆ Gas B is introduced to the evacuated chamber – reacts with surface bound A
  - ◆ excess precursor & reaction by-product removed.
- ◆ Repetition of A – B pulse sequence to build film layer-by-layer

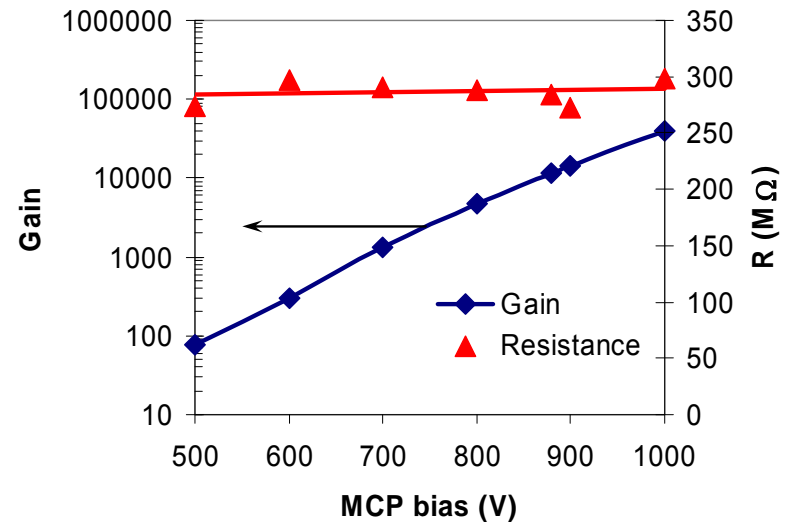




# ALD Functional Films: Substrate Independent MCP



- SE yields >5 possible vs MCP < 3
- Conductivity range > 7 orders of magnitude
- Ohmic conduction, Stable in applied E field, TCR < 1%

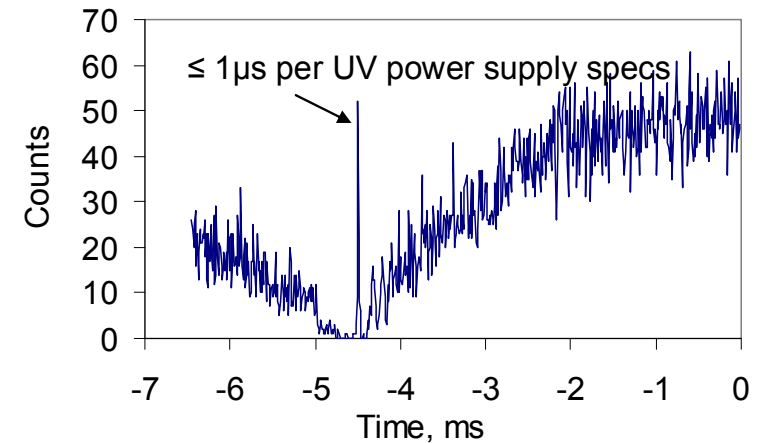
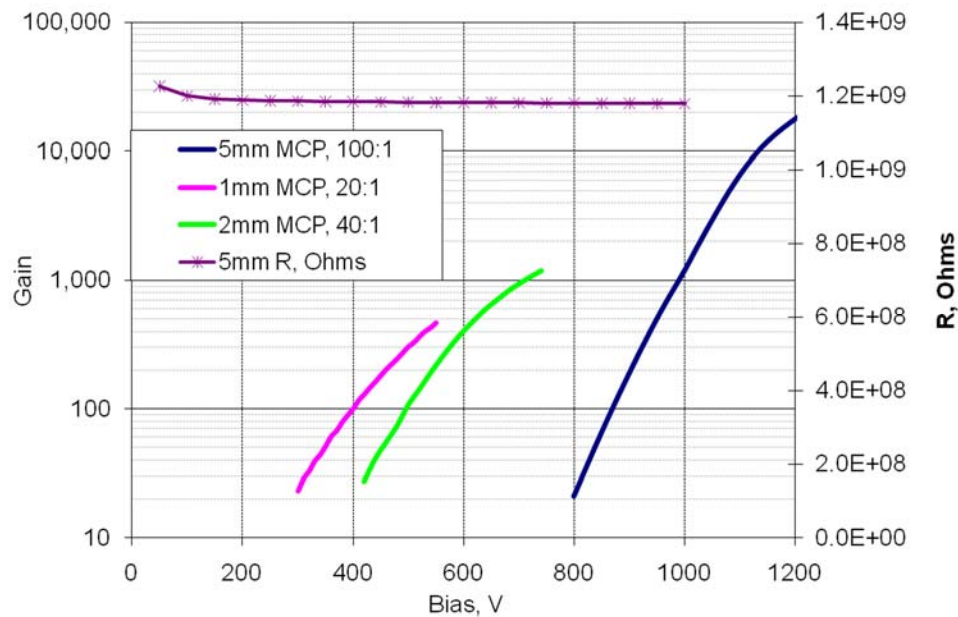
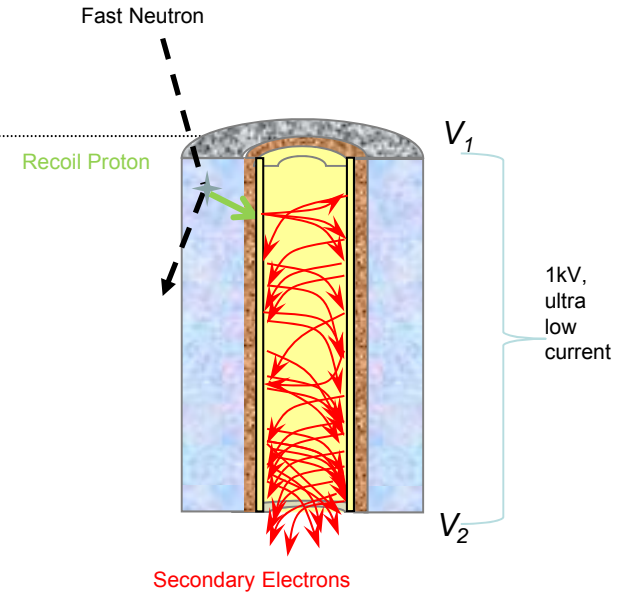


- 10 μm pore, Soda Lime glass substrate, 40:1 L/D, R~280 MW
- 5-10x gain increase vs. commercial MCPs



# Fast Neutron Detection Technology

- ◆ Hydrogen-rich PMMA MCP
- ◆ Graded Temperature ALD
  - ◆ Active films deposition at 140C
- ◆ Proton initiated electron cascade
- ◆ Output pulse  $10^3 - 10^6$  electrons
- ◆ Standard readout electronics



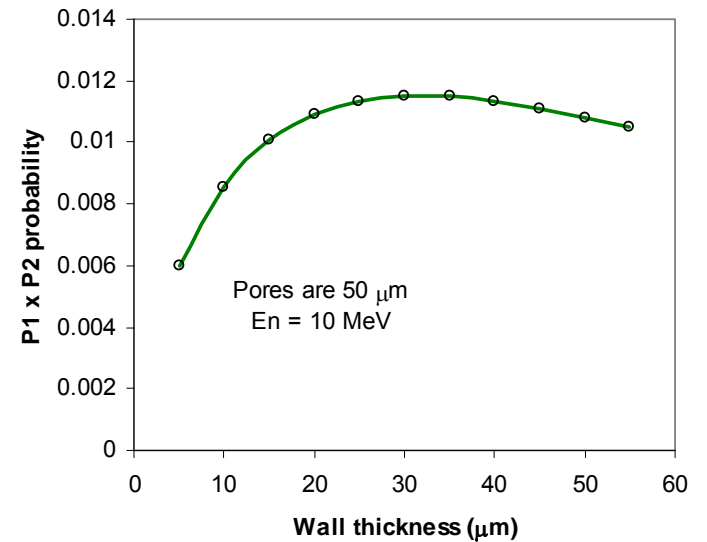
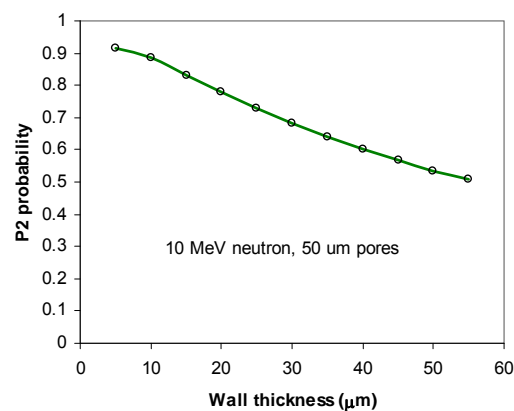
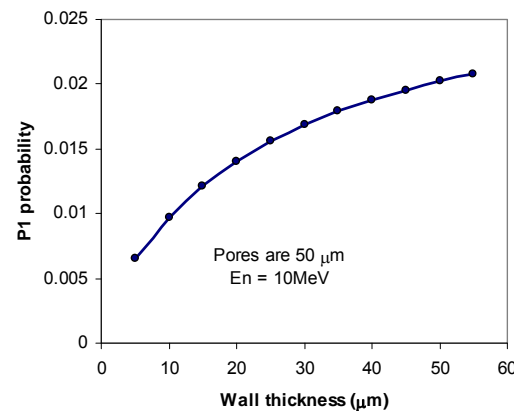
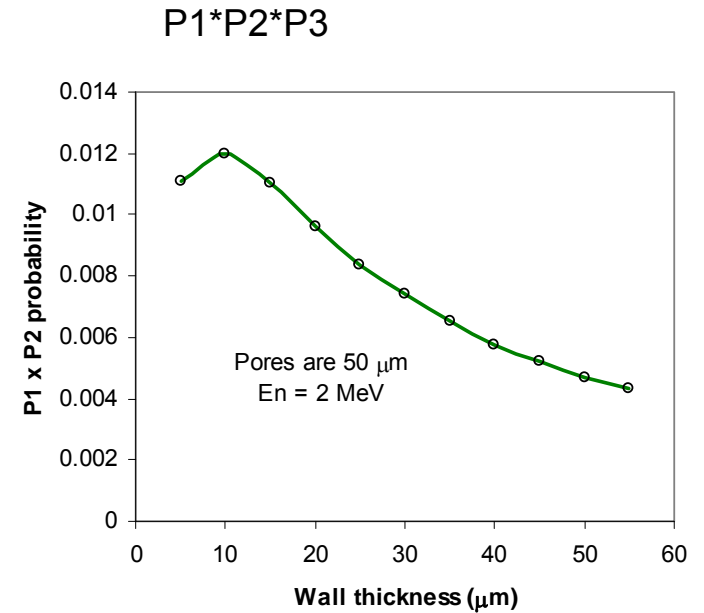
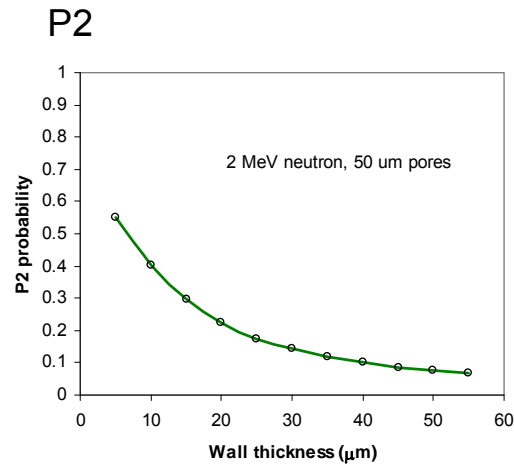
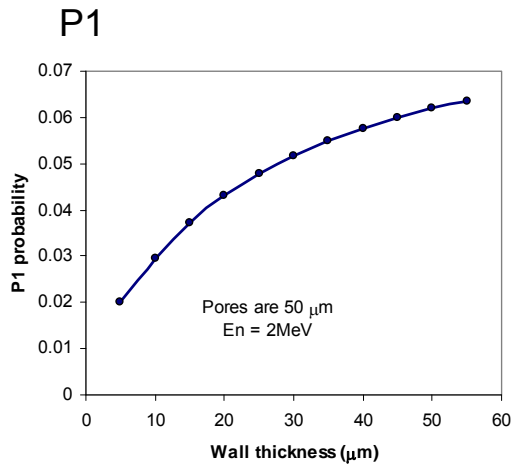
Timing histogram of events detected under 120Hz-modulated UV illumination.



# Fast Neutron Detection Simulation: P1 and P2 Probabilities

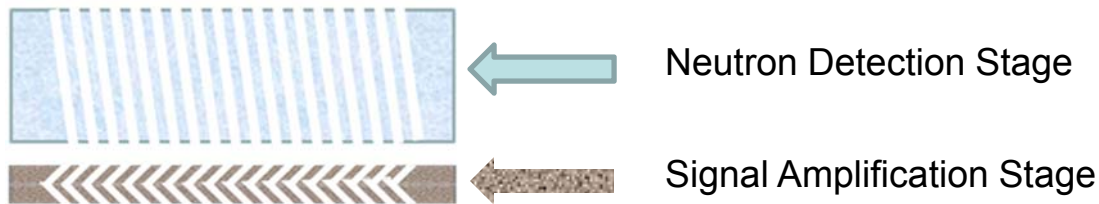
$$P_{\text{detection}} = P_1 * P_2 * P_3$$

- $P_1$  – n-p recoil within the MCP substrate
- $P_2$  – proton escape into MCP pore
- $P_3$  – electron avalanche is formed (MCP ~ 1)





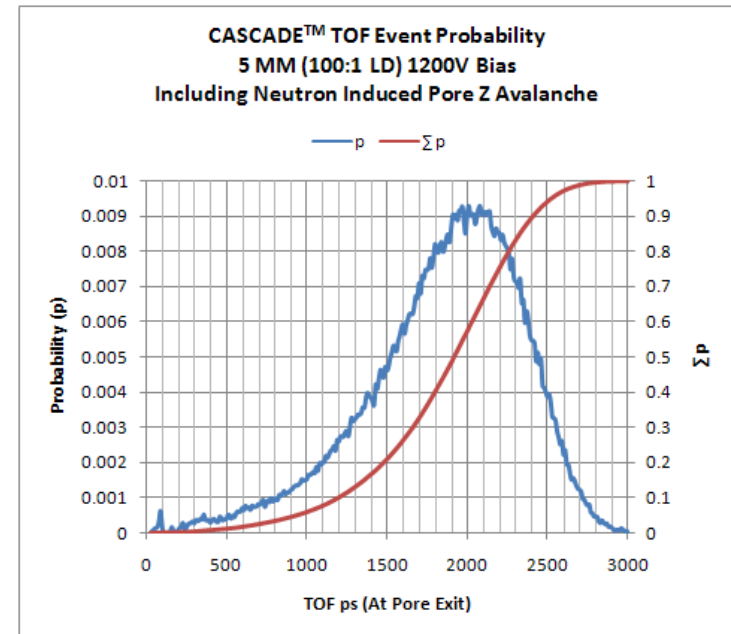
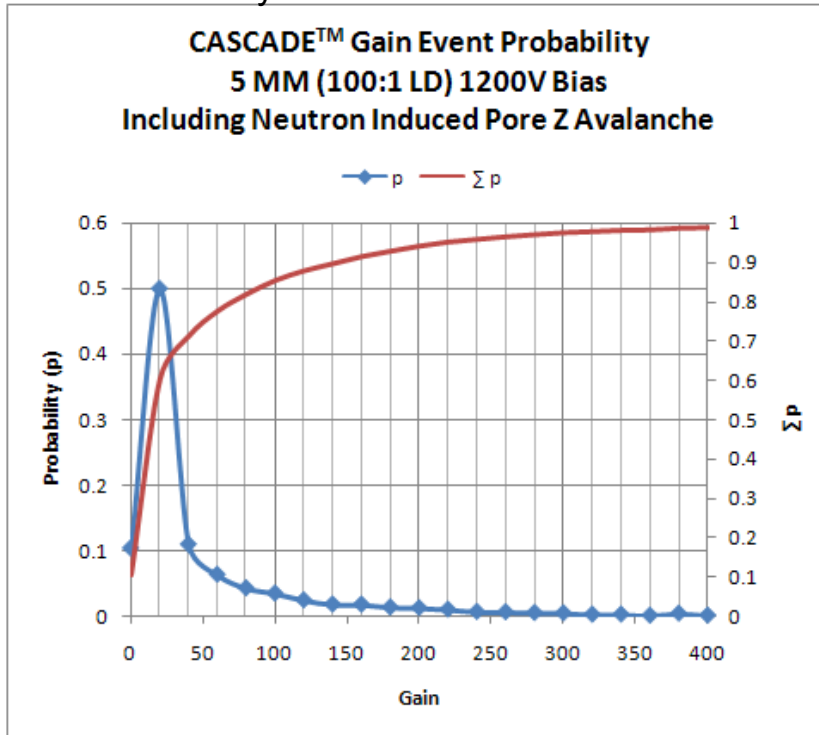
# Fast Neutron Detection Simulation: P3 Probability and Event Timing



Note:  
P3 – Probability for Amplification Stage is 1.0

Timing for Amplification Stage is < 200 ps

Operating at 1200V Bias (Average Gain 47)  
P3 - Probability 0.9 for 100:1 LD 50 um Pores



For 99.9% of events, we should expect a pulse timing uncertainty in coincidence mode of operation of  $\pm 1.5$  ns

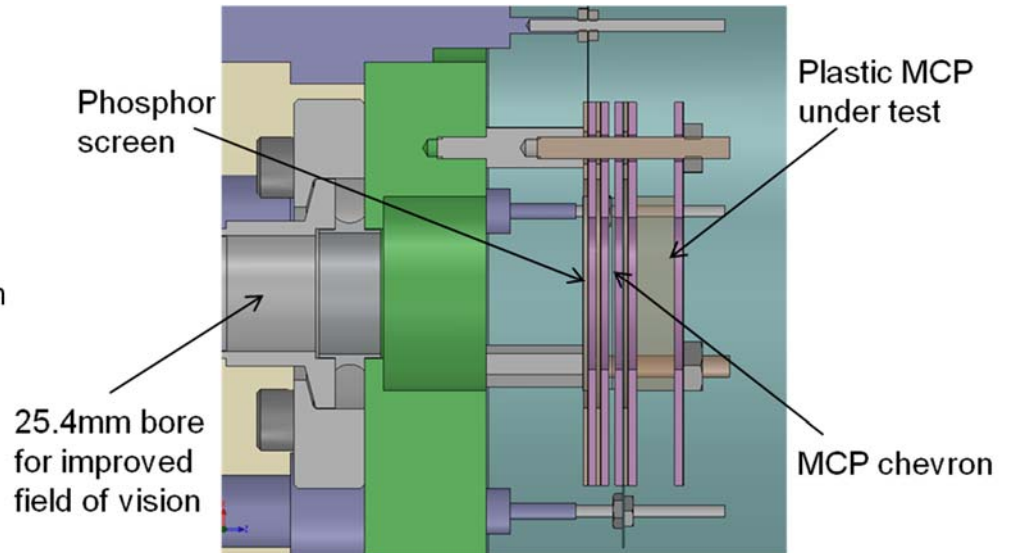
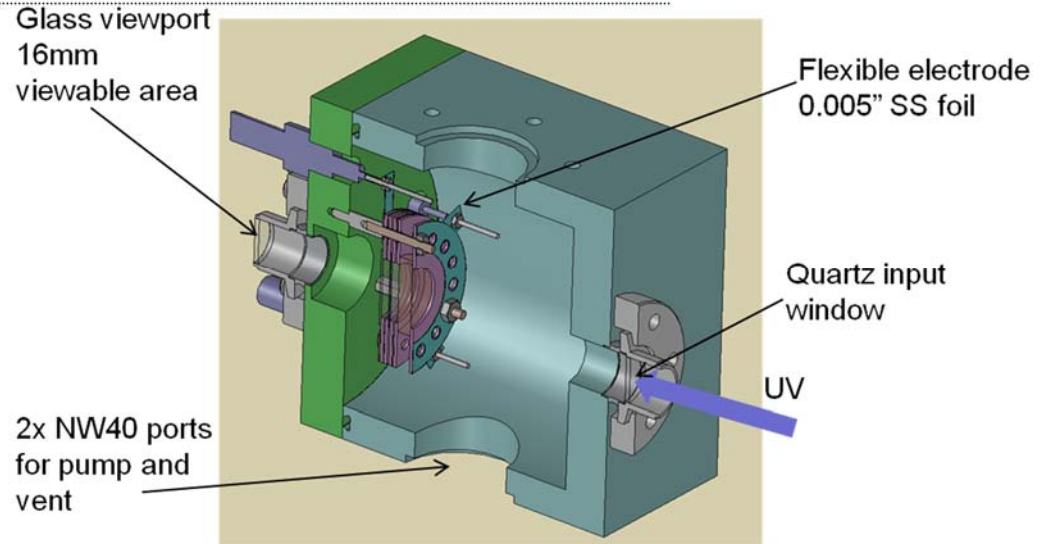
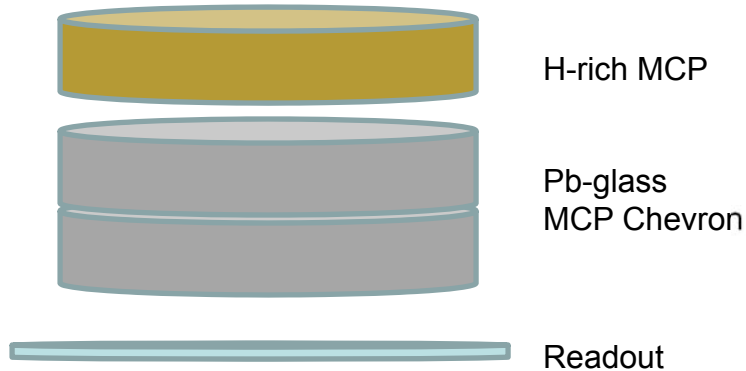
For 90% of events, we should expect a pulse timing uncertainty in coincidence mode of operation of  $< \pm 1.0$  ns





# Detector Hardware Experimental Setup

- ◆ 2 & 5 mm PMMA MCP, ~50  $\mu\text{m}$  pores, 20  $\mu\text{m}$  walls, 5° bias angle
- ◆ installed above a chevron stack of 50:1 L/D MCPs
- ◆ Phosphor screen readout
- ◆ Canberra preamp and postamplifier

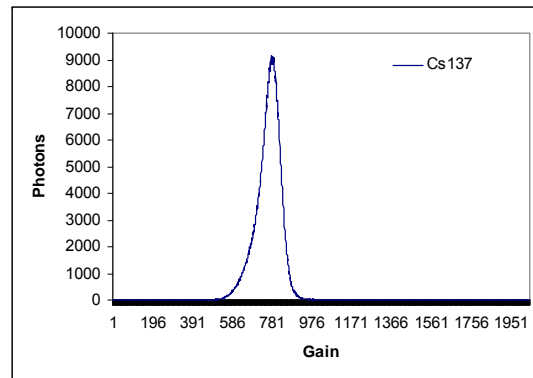
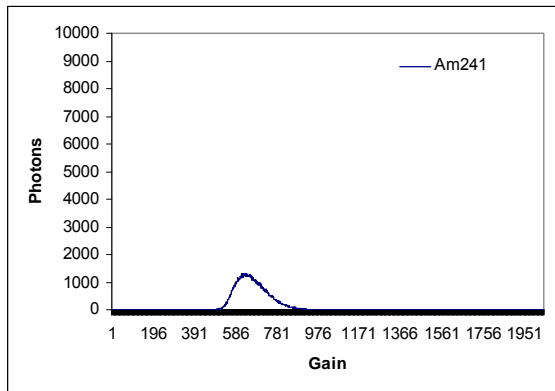




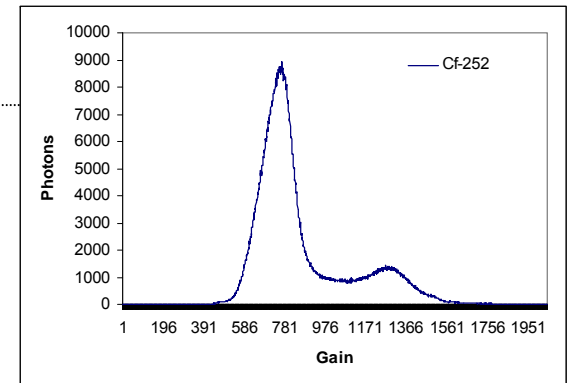
# Isotope Sources: Experimental Setup

	Am-241	Cs-137	C-60	Cf-252
	1.9 mQ	760 $\mu$ Q	43.7 $\mu$ Q	
Gamma (keV)	36% @ 60, 38% @ 12-22	661	1.17; 1.33	
Flux MCP/s	$1.76 \times 10^5$	$7.03 \times 10^4$	$8.08 \times 10^3$	$\sim 10^7$

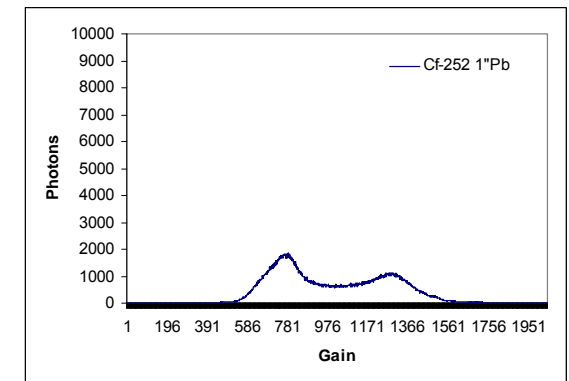
- Isotopes ~15cm from liquid scintillator detector spectra collected over 110s (real time).
- Mesytec MPD-4. is used to record PMT data



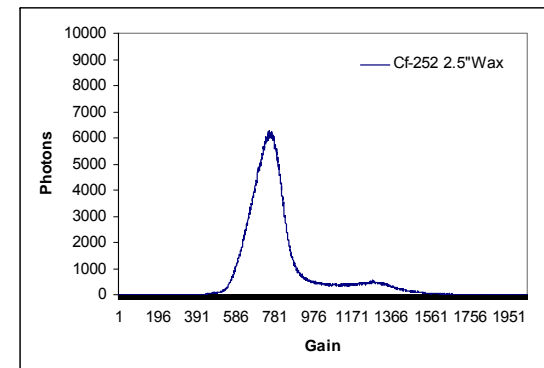
No filters



1" Pb



2.5" Wax

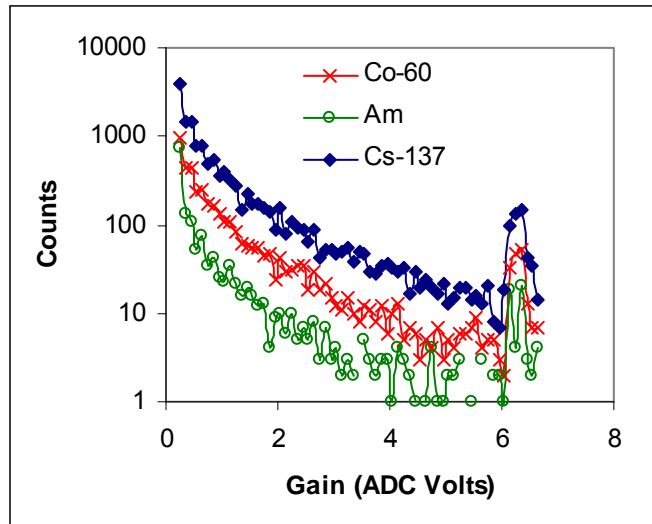


## Reduction of flux by filters

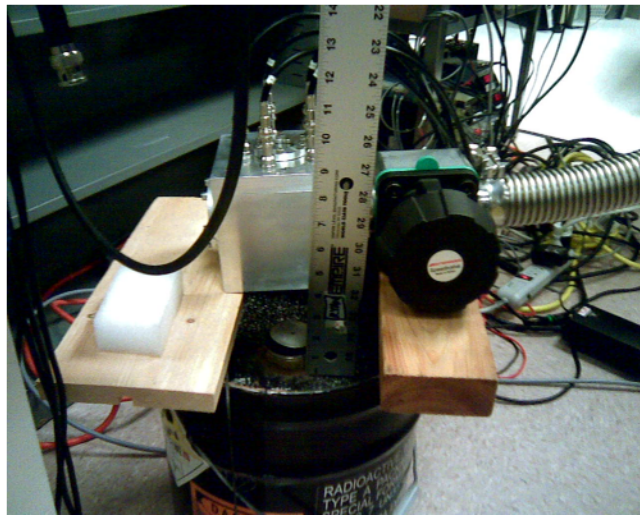
	Gamma	Neutron		Gamma	Neutron
Pb	0.251328	0.778787			
			Wax	0.697481	0.384746



# Gamma Isotope Sources MCP Results Summary

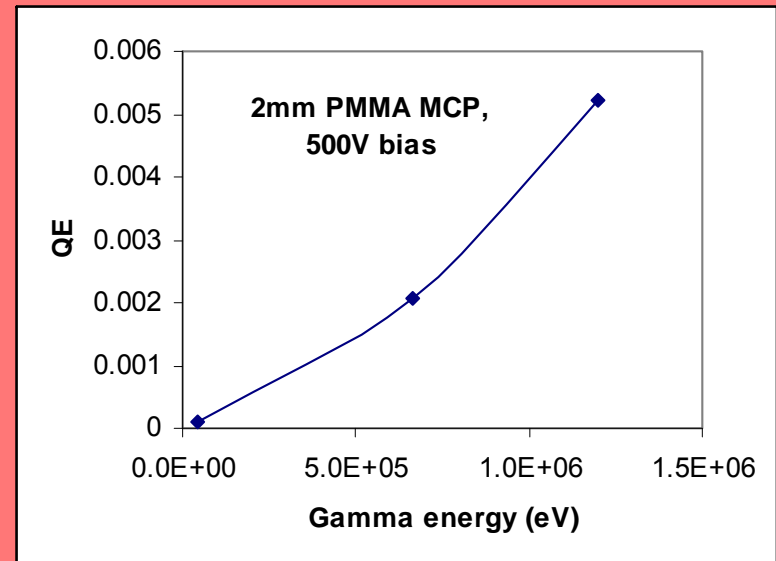


◆ PMMA, 2mm, > 100k 50  $\mu$ m Pores, 20 $\mu$ m wall



## $\gamma$ isotopic sources

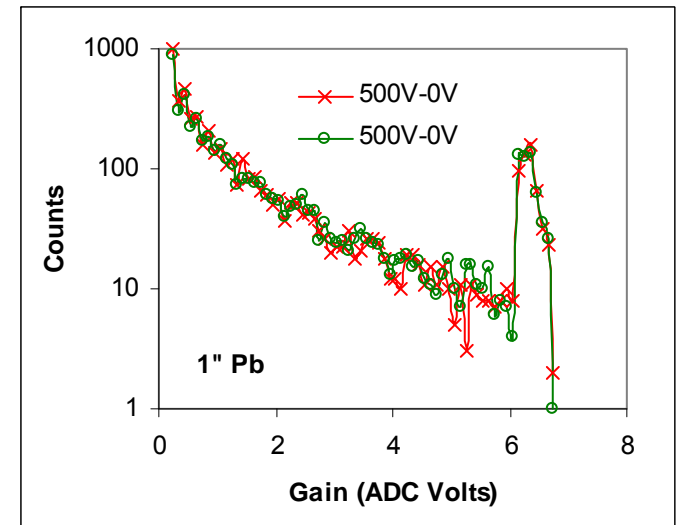
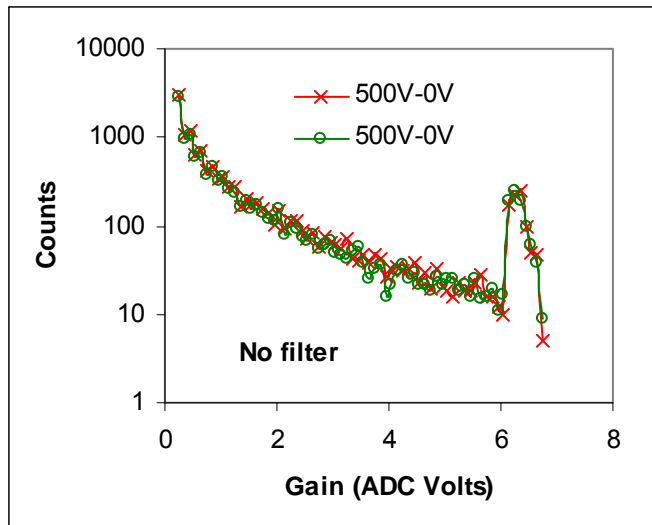
Gamma E (eV)	QE
4.00E+04	9.26E-05
6.61E+05	2.06E-03
1.20E+06	5.22E-03





# Cf-252 MCP Experimental Results Summary

Counts in 96 seconds detected by PMMA MCP only (chevron subtracted)



Filter	Count rate (cps/detector)
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no	125
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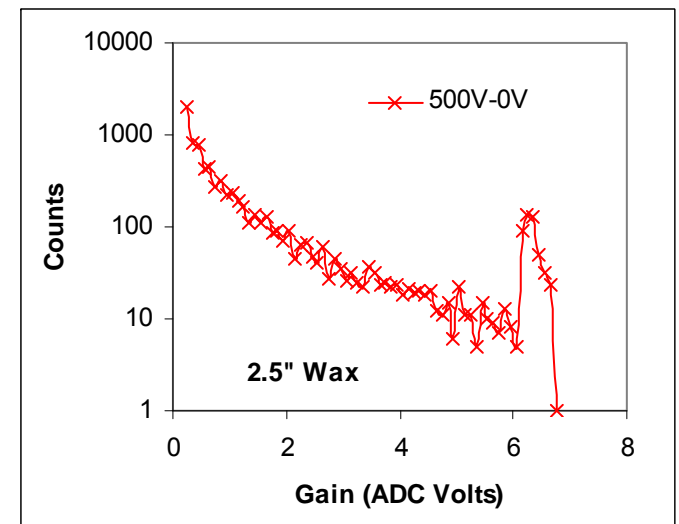
1" Pb	52
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2.5" wax	83
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$$\gamma \text{ QE} = 0.000885$$

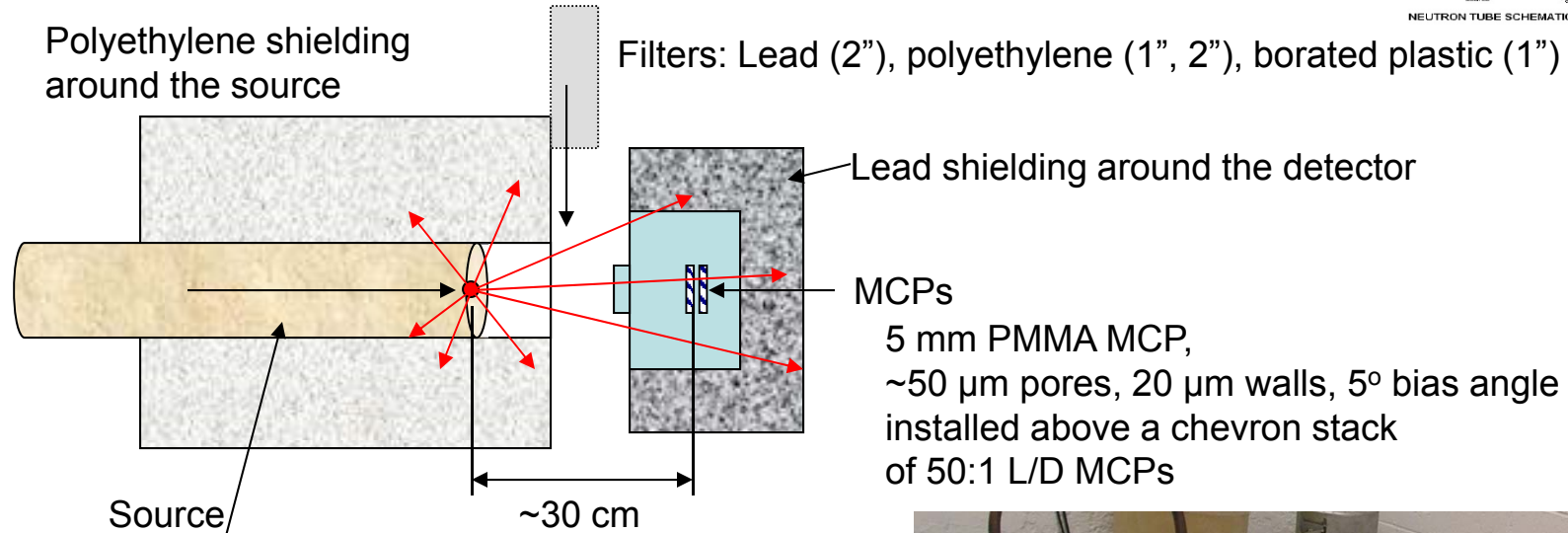
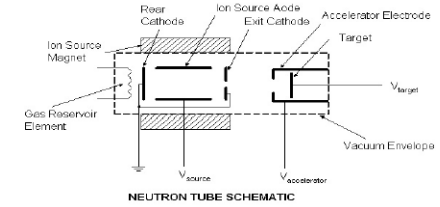
$$n \text{ QE} = 3.28\text{E-}03$$

n QE well matched to simulation





# D-T Source (Thermo 320) Experimental Setup

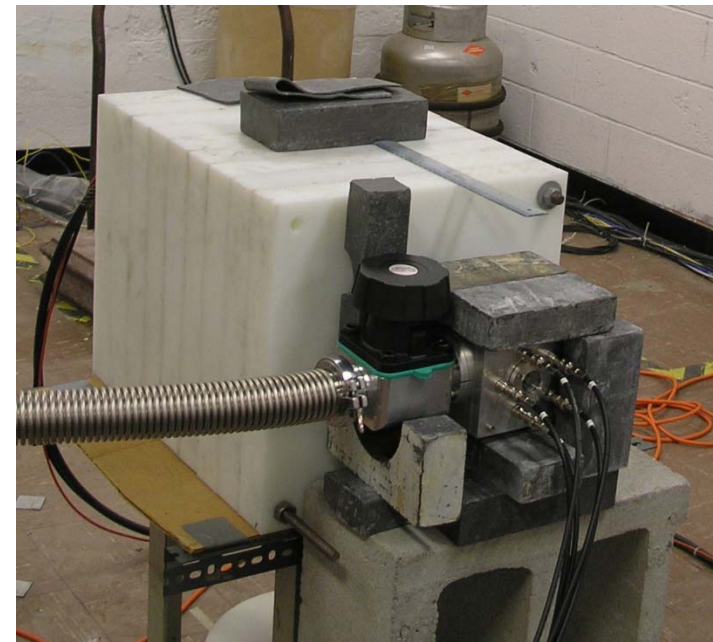


5 mm PMMA MCP,  
~50  $\mu\text{m}$  pores, 20  $\mu\text{m}$  walls, 5° bias angle  
installed above a chevron stack  
of 50:1 L/D MCPs



### Technical Specifications

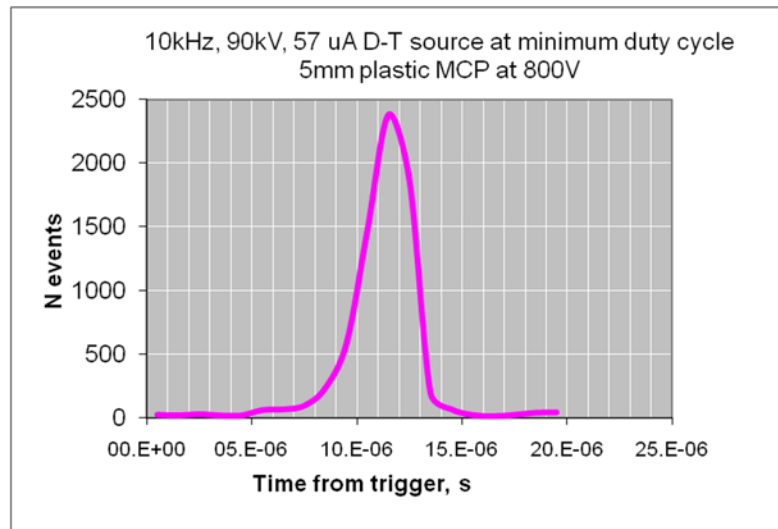
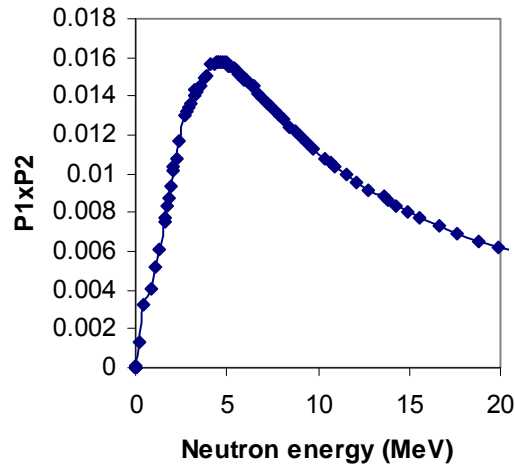
Neutron Yield	1.0E+08 n/s
Neutron Energy	14 MeV
Typical Lifetime	1,200 hours @ 1x10 <sup>8</sup> n/s
Pulse Rate	250 Hz to 20 kHz, continuous
Duty Factor	5% to 100%
Minimum Pulse Width	5 $\mu\text{sec}$
Pulse Rise Time	Less than 1.5 $\mu\text{sec}$
Pulse Fall Time	Less than 1.5 $\mu\text{sec}$
Maximum Accelerator Voltage	95 kV
Beam Current	60 $\mu\text{amps}$





## D-T Source Experimental Results Summary

Predicted QE  $\sim 0.8\%$



### Conclusions:

1. QE to 14 MeV neutrons is  $\sim 1.2\%$
2. Believe n and  $\gamma$  counts are comparable at source settings
3. Timing better than  $1.5 \mu\text{s}$  (measurement limited by the source)
4. MCP dark count very low ( $\sim 0.3 \text{ c/cm}^2/\text{s}$ )



## Conclusions and Future Work

- ◆ Functional films – Improved performance, substrate independence
  - ◆ Emissive Layer - Optimized SE yield and tailored conductivity
  - ◆ Conductive layer - “Ohmic” conduction, Low TCR
- ◆ First Plastic MCP results demonstrated
- ◆ Fast neutron detector demonstration
  - ◆ > 1% Neutron detection simulation target
    - ◆ 2mm MCP QE=0.003
    - ◆ 5mm MCP QE=0.012
  - ◆ < 0.1% Gamma detection “simulation” target
    - ◆ Energy dependence  $QE=9.26 \times 10^{-5} - 5.22 \times 10^{-3}$
- ◆ Future Work
  - ◆ Optimization for Neutron QE > 10%
  - ◆ Gamma Sensitivity
  - ◆ Energy Sensitivity < 500 keV
  - ◆ Demonstrate timing < 1.5ns



## Acknowledgements

◀ Prof. James Ryan



◀ Dr. Richard Lanza

